

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date April 21, 2003

In re the Application of

Akira SATO

Group Art Unit: 2825

Application No.: 09/424,500

Examiner: G. Lee

Filed: February 22, 2000

Docket No.: 104788

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, MOLDING DEVICE FOR SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR DEVICE

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

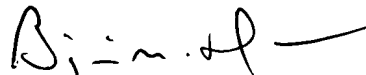
Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired February 19, 2003, an extension of time for a period of two months is hereby requested. (Payment of \$ 110.00 for a one month extension was already made.)

Attached hereto is our Check No. 141469 in the amount of \$300.00 in payment for:

_____	Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
<u>XX</u>	Extension fee for response within second month pursuant to §1.136(a) (\$410.00)
_____	Extension fee for response within third month pursuant to §1.136(a) (\$930.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,



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JAO:BMH/can

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**DEPOSIT ACCOUNT USE
AUTHORIZATION**
Please grant any extension
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